

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant	:	Shimizu, et al.
Appl. No.	:	10/618,900
Filed	:	July 14, 2003
For	:	SINGLE-WAFER-PROCESSING TYPE CVD APPARATUS
Examiner	:	Rudy Zervigon
Group Art Unit	:	1763

AMENDMENT AFTER FINAL**Mail Stop: AF**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action mailed October 19, 2006, please reconsider the present application in light of the following amendments and comments.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.